

Docket No.: 071971-0390

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 53080
	:	
Kunimasa TAKAHASHI, et al.	:	Confirmation Number: 6282
	:	
Patent No.: 7,462,540 B2	:	Issue Date: December 9, 2008
	:	
Application No.: 10/553,845	:	Group Art Unit: 2813
	:	
Filed: October 20, 2005	:	Examiner: Laura M. MENZ
	:	
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING THE SAME	:	

REQUEST FOR CERTIFICATE OF CORRECTION UNDER 37 CFR 1.322

Mail Stop Certificate of Correction
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reviewing the above-identified patent, a printing error was discovered therein requiring correction in order to conform the Official Record in the application.

The error noted is set forth on the attached copy of form PTO-1050 Rev. 2-93 in the manner required by the Commissioner's Notice.

Specifically, on the title page of the patent, under Item "(56) References Cited", under FOREIGN PATENT DOCUMENTS, delete "JP 2002-012482 1/2000"; and change "JP 2002-089551 10/2002" to --JP 2002-289551 10/2002--. Attached, please find copies of the Information Disclosure Statements dated October 6, 2008 and October 20, 2005, which show the correct reference numbers. Also attached are copies of the 1449 forms which indicate the correct reference numbers and are initialed by the Examiner.

10/553,845

The change requested herein occurred as a result of printing the Letters Patent and the Certificate should be issued without expense under Rule 322 of the Rules of Practice. Accordingly, Applicants request issuance of the Certificate of Correction.

Please charge any shortage in fees due in connection with the filing of this paper to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:alb
Facsimile: 202.756.8087
Date: March 17, 2009

**Please recognize our Customer No. 53080
as our correspondence address.**

WDC99 1697676-1.071971.0390

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO : 7,462,540
APPLICATION NO. : 10/553,845
ISSUE DATE : December 09, 2008
INVENTOR(S) : Kunimasa TAKAHASHI, et al.

Page 1 of 1

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the title page of the patent, under Item "(56) References Cited", under FOREIGN
PATENT DOCUMENTS, delete "JP 2002-012482 1/2000"; and
Change "JP 2002-089551 10/2002" to --JP 2002-289551 10/2002--.

MAILING ADDRESS OF SENDER (Please do not use customer number below):

600 13th Street, N.W.
Washington, D. C. 20005-3096

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: ATTENTION Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

Docket No.: 071971-0390



93 IPW
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 53080
Kunimasa TAKAHASHI, et al.	:	Confirmation Number: 6282
Application No.: 10/553,845	:	Group Art Unit: 2813
Filed: October 20, 2005	:	Examiner: Kayra Nart NEBZ
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR PRODUCING THE SAME	:	

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being submitted to correct typographical errors in the Form 1449 originally Submitted on October 20, 2005. The Japanese reference originally listed as JP 2002-012482 should read **JP 2000-012482**. Please note that a copy of the correct reference, JP 2000-012482 was submitted with the original information disclosure statement filed on October 20, 2005. A corrected PTO-Form 1449 is being filed herewith.

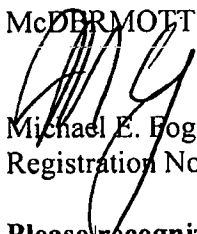
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

10/553,845

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Michael E. Fogarty
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Facsimile: 202.756.8087
Date: October 6, 2008

**Please recognize our Customer No. 53080
as our correspondence address.**



SHEET 1 OF 1

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Substitute for form 1449/PTO)

ATTY. DOCKET NO.
071971-0390SERIAL NO.
10/553,845APPLICANT
Kunimasa TAKAHASHI, et al.FILING DATE
October 20, 2005GROUP
2813**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Codez (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 2000-012482	1/14/2000	FUJI ELECTRIC CO LTD		JAPAN (w/ English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.
1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

10/553845

JCO9 Rec'd PCT/PTO 20 OCT 2005

Docket No.: 071971-0390

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Kunimasa TAKAHASHI, et al.	:	Confirmation Number: Not yet
assigned	:	
Application No.: Not yet assigned	:	Group Art Unit: Not yet assigned
Filed: October 20, 2005	:	Examiner: Not yet assigned
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATION THE SAME	:	

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks
Washington, D. C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. and copies of the references cited were transmitted by WIPO and are believed to be in the file of the above identified application and readily available to the Examiner. Therefore it is

Not yet assigned

JC09 Rec'd PCT/PTO 20 OCT 2005

believed that Applicants have met all requirements regarding duty of disclosure under 37 CFR 1.56. Acknowledgement and consideration of these documents are respectfully requested.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. Since the Search Report was from the U.S. JPO or EPO search authorities, copies of these references should have been supplied to the USPTO under the trilateral agreement and are believed to be in the file of the above identified application and readily available to the Examiner.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Michael E. Fogarty
Registration No. 36,139

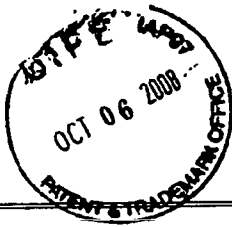
**Please recognize our Customer No. 20277
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600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:aph
Facsimile: 202.756.8087
Date: October 20, 2005

JC09 Rec'd PCT/PTO 20 OCT 2005

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)		ATTY. DOCKET NO. 071971-0390		SERIAL NO. Not yet assigned	
		APPLICANT Kunimasa TAKAHASHI, et al.			
		FILING DATE October 20, 2005		GROUP Not yet assigned	
U.S. PATENT DOCUMENTS					
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		JP 2002-012482	1-14-2000	FUJI ELECTRIC CO LTD	w/English Abstract
		JP 2002-184714	6-28-2002	DENSO CORP	
		JP 2001-068428	3-16-2001	FUJI ELECTRIC CO LTD	
		JP 2002-289551	10-4-2002	DENSO CORP	
		JP 2002-016013	1-18-2002	NISSAN MOTOR CO LTD	
		JP 2002-314071	10-25-2002	DENSO CORP	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)					
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
EXAMINER		DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.



SHEET 1 OF 1

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Substitute for form 1449/PTO)

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Kunimasa TAKAHASHI, et al.FILING DATE
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EXAMINER
/Laura Menz/DATE CONSIDERED
10/26/2008

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Include copy of this form with next communication to applicant.
1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.M./

JCO9 Rec'd PCT/PTO 20 OCT 2005

INFORMATION DISCLOSURE CITATION IN AN APPLICATION						ATTY. DOCKET NO. 071971-0390		SERIAL NO. Not yet assigned			
						APPLICANT Kunimasa TAKAHASHI, et al.					
(PTO-1449)						FILING DATE October 20, 2005		GROUP Not yet assigned			
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				JP 2001-068428		3-16-2001	FUJI ELECTRIC CO LTD				
				JP 2002-289551		10-4-2002	DENSO CORP				
				JP 2002-016013		1-18-2002	NISSAN MOTOR CO LTD				
				JP 2002-314071		10-25-2002	DENSO CORP				
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EXAMINER /Laura Menz/						DATE CONSIDERED 08/16/2008					

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.M./